Transducers for Data Acquisition and Testing

February 2017



Meet VR





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- Accelerometer Construction
- IEPE Supply and T.E.D.S.
- Selecting the right Accelerometer
- Configuring an Input
- Input Settings in VibrationVIEW



- Piezoelectric sensors
- Dynamic vs. Static Measurement
- IEPE Designs
- IEPE Transducer Characteristics
- Charge Mode Transducer Characteristics
- Mounting Considerations
- Transducer Selection
- TEDS
- Handling





- Why Piezoelectric Sensors?
 - Small Size
 - Lightweight
 - 2-Wire operation (IEPE)
 - Wide Range
 - Dynamic Range
 - Temperature Range
 - Frequency Range
 - Low Noise Floor
 - Simple Signal Conditioning
 - Cost Effective Implementation





- Common Testing Environments for Piezoelectric Sensors:
 - Modal Analysis
 - Environmental Stress Screening (ESS)
 - Health and Usage Monitoring Systems (HUMS)
 - Predictive/Preventative Maintenance
 - Pyrotechnic Events
 - Aircraft Flight Monitoring
 - Vibration Testing





- Piezoelectricity
 - Definition:
 - Piezoelectricity is the ability of some materials (notably crystals and some ceramics) to generate an electrical potential in response to applied mechanical stress. This may take the form of a separation of electrical charge across the crystal lattice. If the material is not short-circuited, the applied charge induces a voltage across the material. The word is derived from the Greek word piezien, which means to squeeze or press
 - The crystal converts mechanical energy into electrical energy
 - Types of piezoelectric materials:
 - Quartz, Tourmaline, Ceramic (PZT), GAP04....



- Transducers come in many different sizes and shapes.
- Red → Piezoelectric Crystals
- Grey → Seismic Mass
- Arrows indicate direction of stress
- Shear Configuration
 - Most common for accelerometers
 - Wide frequency range
 - Low off axis sensitivity
 - Low sensitivity to base strain
 - Low sensitivity to thermal input





- Force, Pressure and Acceleration
 - − Blue → Sensor Housing
 - Red \rightarrow Piezoelectric Crystals
 - Black \rightarrow Electrode, where charge builds
 - Yellow → Microcircuit
 - Green \rightarrow Seismic Mas
- Seismic mass is forced to follow the motion of the base. Resulting force on the crystals is calculated by Newtons Second Law of Motion: F=MA





Piezoelectric Transducers

- The active element is a piece of piezoelectric material. When compressed a particular voltage output can be measured based on the amount of force being applied to the material.
- Common types of Piezo Sensors:
 - Voltage Mode (IEPE, LIVM, ICP, Piezotron, Isotron)
 - Charge Mode





Compression



Planar Shear





Annular Shear

Shear



• IEPE/ICP Power Supply

- 2 Wire System
- Common wire for power and signal
- Additional conductor for signal ground

- Supply Specs
 - 18-30 VDC
 - 2-4 mA DC
 - Constant Current supply



Transducer Electronic Data Sheet (TEDS)

	Manufacturer ID	43 (Accel MFG 123)
Pacie TEDS	Model Number	7115
Dasic ILDS	Version Letter	В
	Serial Number	X001891
	Calibration Date	Feb 29, 2016
	Sensitivity @ ref. condition (S ref)	10.123 mV/G
Standard and Extended	Physical measurement range	± 500G
TEDS (fields will yory	Electrical output range	± 10V
according to transducor	Reference frequency (F ref)	100.0 Hz
	Quality factor @ Fref (Q)	300 E-3
type)	Temperature Coefficient	-0.48 %/°C
	Reference temperature	23°C
	Sensitivity direction (x,y,z)	Х
Liser Area	Sensor Location	Strut AB12
USEI AIEd	Calibration due date	Feb 28, 2017



- Voltage Mode Transducers
 - Utilize some type of quartz or ceramic piezo material
 - Built in Electronics
 - Low Cost Signal Conditioning
 - Limited upper temperature range due to onboard electronics
 - Modern analyzers, DAQ's, and controllers have IEPE power built in
 - Available with TEDS (Transducer Electronic Data Sheet)
 - Easy to configure, connect, and use







measure. analyze. innovate.

MEGGITT

Endevco

DJB Instruments

- Sensor Resonance
 - Accelerometers are a spring mass system
 - Has a natural resonance
 - When selecting an accelerometer:
 - For Error < 4% ensure the natural frequency is AT LEAST 5x greater than the highest frequency measured
 - For Error < 1% ensure the natural frequency is 10x greater!









- Mounting Considerations
 - Probe Tip
 - 2-Pole Magnet
 - Flat Magnet
 - Adhesive Mounting Pad
 - Adhesive
 - Stud

- Handling of Transducers
 - Do NOT!:
 - Drop the sensor on the floor
 - Connect a bench power supply to the sensor
 - Remove the sensor with a hammer
 - Use Un-Calibrated Sensors
 - Apply static discharge to accelerometers
 - DO:
 - Store the sensor in the box it came in
 - Connect a constant current supply
 - Remove the sensor using solvent or the proper tool
 - Re-calibrate the sensors
 - Properly ground before handling the sensor





Selecting the Right Accelerometer

PHYSICAL Weight Connector Mounting Provi Material, Housi Sensing Eleme

Element Style PERFORMANC Sensitivity, ± 5% Range for ± 5 V Frequency Resy Resonant Frequ Broad Band Res Linearity [2] Maximum Trans Strain Sensitiviti

ENVIRONMEN' Maximum Vibral Maximum Shoci Operating Temp TEDS Operating Seal ELECTRICAL Supply Current Compliance Vol Output Impeden Bias Voltage Discharge Time Electrical Isolativ TEDS

- 10mV/G Accelerometer
 Max Acceleration
- 100 mv/G Accelerometer

1000 mv/G Accelerometer

G		• HERMETICALLY SEALED • BASE ISOLATED • IDEAL LOW FREQUENCY RESPONSE • TEDS											
-		ENGLIS	н	SI									
ion g/Connector It	Type Tapped Hole	0.35 10-32 10-32 X.150 j Titanium Ceramic Planar Shear	0Z	10 10-32 10-32 X.150 ↓ Titanium Ceramic Planar Shear	grams								
E [1] bits Output vonse, ± 10% ency volution verse sensitivity		10 500 1 to 10000 > 32 0.0040 ± 1 5	mV/g Hz kHz Grms % F.S.	1 4905 1 to 10000 > 32 0.039 ± 1 5	mV/m/s ² m/s ² Hz kHz m/s ² rms % F.S. %								
@ 250µ£		0.002	g/με	0.02	m/s²/µɛ								
rAL ion c erature Range Temperature		600 3000 -60 to +250 -40 to +185 Hermetic	Gpeak Gpeak *F *F	5886 29430 -51 to 121 -40 to +85 Hermetic	m/s² peak m/s² peak *C *C								
Range [3] lage Range ce,Typ Constant on		2 to 20 18 to +30 20 11 to 13 0.5 to 1.5 10 IEEE 1451.4	mA Volts Ω VDC Sec GΩ,min	2 to 20 18 to +30 20 11 to 13 0.5 to 1.5 10 IEEE 1451.4	mA Volts Ω VDC Sec GΩ,min								



Input Configuration

Vib	ration	VIEW C	onfi	guration	1												×
	Parameters Directories					Users				Verificat	ion		Graph Defaults				
Hardware Inputs Out			Output	s Units	Limits R				note In	puts	E-	Mail Not	il Notification Web Se				
	Saved	Configu	ratior	1						-							
				Load configurat						gurati	ation Save configuration						
	Channel ID Serial Label Number			Sensitivity U				Unit D				on	Accel Power	r TEDS			
>>	1 Ch	1			~		10		mV /	G			\sim				
	2 Chi	2			~		10		mV /	G			\sim				
	3 Chi	3			~		10		mV /	G			\sim				
	4 Ch	4			~		10		mV /	G			\sim				
													-				
													Re	ad All EDS	Databa Selecto	se A or :	dvanced Settings
									(ОК		Ca	ncel		Apply		Help



Input Settings in VibrationVIEW

	Advanced Input Configu	uration																			Х
Sav	ed Configuration																				
				Lo	oad configuration	Save configuration															
	Channel Label	ID	Serial Number	Axis	Transducer Sens	itivity	Calibration Date	1	Accel . Power	TEDS	Low Bias V C	Cap D Duple Ing	iff DC out Input	Invert	Range (Volts)	Manufactu	ırer	Model	1	Гуре	
» 1	¢h1		~		~ 10	mV/G									Auto	~		~		~	
2	Ch2		~		~ 10	mV/G									Auto	~		~		~	
3	Ch3		~		~ 10	mV/G									Auto	~		~		~	
4	Ch4		~		~ 10	mV/G									Auto	~		~		~	
											Show Condition	ers	Read All TEDS	Data Sa	abase ave	Database Lookup	ОК	Cancel	Apply	Help	



Conclusion

• Questions?

 If you want the slides or want to ask questions at a later time, please email in to <u>vrsales@vibrationresearch.com</u> or feel free to call in at 616-669-3028

• Thanks!

